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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application: Joon Hyeon LEE } GRP ART UNIT: 2812
Serial No: 10/622,351 } Ex.: Isaac, Stanetta D.
Filed: July 18, 2003 }
For: METHOD FOR FORMING ISOLATION FILM FOR SEMICONDUCTOR
DEVICES

Certification under 37 C.F.R. §1.8(a)

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I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted to the United States Patent and Trademark Office to the fax number and on the date indicated above.


Richard J. Streit, Reg. No. 25,765

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450


APPOINTMENT OF ASSOCIATE ATTORNEY

Dear Sir:

The undersigned Attorney for Applicant in the above identified application for Letters Patent, hereby appoints **Woochoon William Park, Reg. P-55,523** as my Associate Attorney, to prosecute this application, to make alterations and amendments therein, to receive the patent, and to transact all business in the United States Patent & Trademark Office connected therewith.

Please address and send all correspondence to:

Richard J. Streit
Ladas & Parry
224 South Michigan Avenue
Chicago, Illinois 60604
Customer No. 26530

Dated: January 15, 2004
Richard J. Streit, Reg. 25,765
c/o Ladas & Parry
224 South Michigan Avenue
Chicago, Illinois 60604
(312) 427-1300